NOTES:

1. SUBSTRATE:

FUSED SILICA

2. COATING (APPLY ACROSS CLEAR APERTURE)

\$1: Ultrafast (750-850nm)

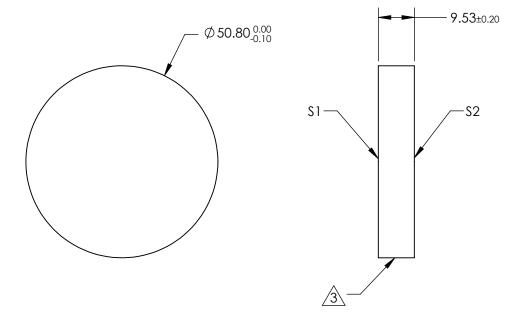
R(AVG) S&P > 99.90% @ 800nm R(AVG)> 99.7% @ 750 - 850nm

GDD SPECIFICATION: ±20 fs2@ 750 - 850nm @ 45° AOI

S2: NONE



4. ROHS COMPLIANT



FOR INFORMATION ONLY: DO NOT MANUFACTURE PARTS TO THIS DRAWING

SPECIFICATIONS SUBJECT TO CHANGE WITHOUT NOTICE DIMENSIONS ARE FOR REFERENCE ONLY

SHAPE	\$1 PLANO	S2 PLANO			B	Edmund Optic	CS®
SURFACE QUALITY	10 - 5	COMMERCIAL POLISH	THIRD ANGLE PROJECTION		TITLE	Low-GDD Ultrafast Dielectric Mirror, 800nm, 45° AOI, 50.8mm Dia., 9.53mm Thick	
CLEAR APERTURE	Ø 45.72	N/A					
SURFACE FLATNESS	λ/8 over 70% CA	N/A	1			·	
BEVEL	PROTECTED AS NEEDED	PROTECTED AS NEEDED	ALL DIMS IN	mm	DWG NO	26831	SHEET 9 OF 24